

Abstract

Noise Analysis of MEMS Microphones as a Gas-Sensing Element [†]

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Abstract: In recent years, micromachined microphones have evolved into versatile transducers for gas-sensing applications in the fields of both direct and indirect photoacoustics. However, their noise properties have not yet caught much attention. In this contribution, we present an analysis of the noise spectrum of a MEMS microphone and show how it may be employed as a gas-sensing tool and to characterize photoacoustic detectors. The results highlight the potential to determine the speed of sound, ambient temperature, and gas composition via Fourier analysis of the microphone noise.

Keywords: MEMS microphones; gas sensor; acoustic resonance; noise analysis

1. Introduction

MEMS microphones have the potential to serve as transducers not only for sound-waves as such but also for detecting gases. In the last decade, miniaturized photoacoustic setups have been demonstrated wherein MEMS microphones serve as transducers to determine the light intensity [1]. In particular, in indirect photoacoustic setups, the use of acoustic resonances is often not desirable [2] because it introduces undesired dependencies, e.g., on ambient temperature. Instead, a constant sensitivity in a broad acoustic frequency spectrum enables simultaneous, selective multi-gas detection by analyzing multiple frequencies in parallel [3]. Recently, the resonance of MEMS microphone microstructures [4] has also been used in a direct, laser-based photoacoustic setup.

However, to date, the noise spectrum of bare MEMS microphones has been largely omitted as a means for gas sensing. Nonetheless, the analysis of MEMS microphone noise may be employed as a gas species- and temperature-sensing tool.

2. Materials and Methods

Micromachined silicon microphones feature a low-quality acoustic resonator due to the design of the sensing chip [5]. To analyze the noise spectrum, the signal of a MEMS microphone ICS-40720 from Invensense-TDK (Tokyo, Japan) was amplified and its noise spectrum recorded. First, photoacoustic detectors were produced with various gas compositions at 1 bar pressure and fillings of 100% synthetic air, 100% methane (CH₄), and 100% carbon dioxide (CO₂). Figure 1 shows the recorded noise spectrum, from which the Q-factor of the resonators was calculated.



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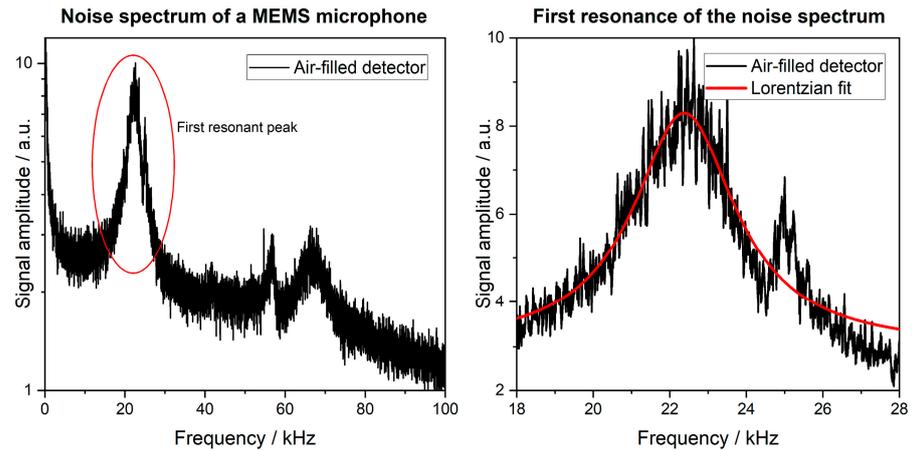


Figure 1. (Left): Noise spectrum measured for an ICS-40720 microphone encapsulated in a synthetic-air atmosphere. (Right): The first resonant peak of the microphone’s noise fitted to a Lorentzian shape. The resonant frequency was determined by its geometry, the speed of sound in the gas, and the temperature.

3. Discussion

From the results in Figure 2, a marked shift in the microphone’s resonance frequency when encapsulated in atmospheres with different gas compositions is evident. For CH₄, which features a higher speed of sound than synthetic air, the shift happened upwards in frequency; the opposite effect took place for CO₂. The obtained square root of the dependency of the resonant frequency with the speed of sound deviates from the linearity expected in a Helmholtz resonator. Therefore, further exploration with different gases must be conducted to verify this tendency. The same is true for the behavior of the second resonance that was observed. Therefore, the concept of microphone noise measurement as a method for the detection of different gas compositions has been verified. The dependency of the speed of sound with temperature suggests it can be determined in this way.

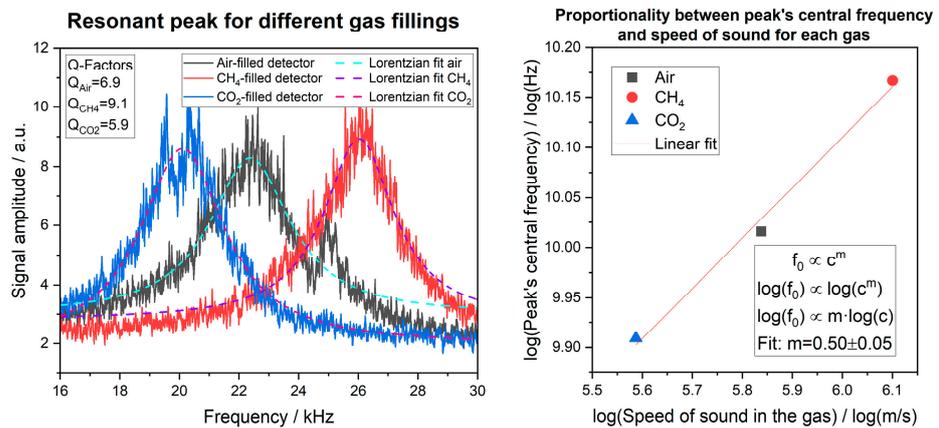


Figure 2. (Left): Noise spectrum recorded for microphones encapsulated in atmospheres with different gas compositions. (Right): Relationship between the resonance frequency at the first peak and the speed of sound in the atmosphere of each sensor. Note the rather exact 0.5 exponent in the proportionality.

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